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|---|---|--|---|--|---------------------------|--------------------------------|
| SERIAL NUMBER 10/524,610 | FILING or 371(c) DATE 08/11/2005 RULE | CLASS 257 | GROUP ART UNIT 2818 | ATTORNEY DOCKET NO. 10191/4116 | | |
| APPLICANTS Franz Laermer, Weil Der Stadt, GERMANY; Lutz Mueller, Aichtal, GERMANY; Winfried Bernhard, Gerlingen, GERMANY; ** CONTINUING DATA ***** This application is a 371 of PCT/DE03/01437 05/06/2003 ** FOREIGN APPLICATIONS ***** GERMANY 10237787.1 08/17/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** | | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /HOANG-QUAN TRAN HO/ Acknowledged Examiner's Signature | | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY GERMANY | SHEETS DRAWINGS 1 | TOTAL CLAIMS 17 | INDEPENDENT CLAIMS 2 |
| ADDRESS KENYON & KENYON LLP ONE BROADWAY NEW YORK, NY 10004 UNITED STATES | | | | | | |
| TITLE Layer system comprising a silicon layer and a passivation layer, method for production a passivation layer on a silicon layer and the use of said system and method | | | | | | |
| FILING FEE RECEIVED 1030 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | | |